TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. 11675.114	
Application (*): ADEMA Kei-Yu Ko				
Serial No.	Filing Date	Examiner	Group Art Unit	
08/846,671	April 30, 1997	George A. Goudreau	1763	
ide. UNDOPED SILICO	N DIOXIDE AS ETCH STOP	FOR SELECTIVE ETCH OF DOP	ED SILICON DIOXIDE	
	Assistant Con	ddress to: nmissioner for Patents gton, D.C. 20231		
of a national applie three months of th application; before	cation other than a continued e date of entry of the national the mailing of a first Office Ac g of a request for continued e	I herewith is being filed within three prosecution application under 37 stage as set forth in 37 CFR 1.45 tion on the merits, or before the maxamination under 37 CFR 1.114.	CFR 1.53(d); within	
CFR 1.97(b), provi Final Action under	sclosure Statement submitted ded that the Information Disc	I herewith is being filed after the p closure Statement is filed before to f Allowance under 37 CFR 1.31	he mailing date of a	
☐ the statemen	nt specified in 37 CFR 1.97(e);			
	OR			
★ the fee set for th	rth in 37 CFR 1,17(p).			
		TC 1700	RECEIVE	

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT Order 37 CFR 1.97(b) or 1.97(c))			Docket No. 11675.114	
In Re Application:	SEP 2 1 2001			
Serial No.	Paneral Filing Date	Examiner	Group Art Unit	
08/846,671	April 30, 1997	George A. Goudreau	1763	
UNDOPED SILIC	CON DIOXIDE AS ETCH STOP F	FOR SELECTIVE ETCH OF DOPE	D SILICON	
		ment of Fee ects to pay the fee set forth in 37 CFR 1.1		
☐ Charge t ☐ Credit ar ☐ Charge a ☐ Certificate of	ow. A duplicate copy of this sheet the amount of my overpayment. any additional fee required.  Transmission by Facsimile*  ment and authorization to charge deposition to the United States Office (F	Certificate of Mailing by I	ee is being deposited e U.S. Postal Service C.F.R. 1.8 and is	
(Date)	Signature	Washington, D.C. 20231.		
Signature		Signature of Person Mailing Correspondence		
Typed or Printed !	Name of Person Signing Certificate	Typed or Printed Name of Person	Mailing Certificate	
orney for Applicant	Ph.D.	Dated: September 2/, 2001  US EXMESSMALL ELSAS:		
PATENT TI	RADEMARK OFFICE	SEP 2 6 2007 TC 1700		



PATENT APPLICATION Docket No: 11675.114

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application o	f	)		
	Kei-Yu Ko	)		
Serial No.:	08/846,671	)		
Filed:	April 30, 1997	)		
For:	UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF DOPED SILICON DIOXIDE	) ) )		
Examiner:	George A. Goudreau	)		
SUP	PLEMENTAL INFORMATION DISCLOSURE STAT UNDER 37 C.F.R. § 1.97	EMENT		D T
The Assistant Commissioner for Patents Washington, D.C. 20231			2 & 200	
Sir:		Ŏ	=	1 1

Please find, pursuant to 37 C.F.R. § 1.98(a)(1), the enclosed Form PTO-1449 which contains a list of all patents, publications, or other items that have come to the attention of one or more of the individuals designated in 37 C.F.R. § 1.56(c). While no representation is made that any of these references may be "prior art" within the meaning of that term under 35 U.S.C. §§ 102 or 103, the enclosed list of references is disclosed so as to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56.

Moreover, while no representation is made that a specific search of office files or patent office records has been conducted or that no better art exists, the undersigned attorney of record believes that the enclosed art is the closest to the claimed invention (taken in its entirety) of which

09/28/2001 MITLETER 00000089 00035271 01 FD:286 100.00 07 the undersigned is presently aware, and no art which is closer to the claimed invention (taken in its entirety) has been knowingly withheld.

In accordance with 37 C.F.R. § 1.98(c), all English translations within the possession, custody, control or availability of anyone designated in 37 C.F.R. § 1.56(c) of each non-English reference, if any, are also enclosed.

Since all listed references are either in the English language or are accompanied by a translation into English, no concise explanation of relevance is required under 37 C.F.R. § 1.98(a)(3).

U.S. Patent No.	<u>Date</u>	<u>Name</u>	Class	Sub Class
5,643,819	07-1997	Tseng	437	60
5,936,272	08-1999	Lee	257	306
5,897,352	04-1999	Lin et al.	438	255
5,792,689	08-1998	Yang et al.	438	253
5,712,202	01-1998	Liaw et al.	438	253
5,700,731	12-1997	Lin et al.	438	381
5,731,130	03-1998	Tseng	430	316

Please credit any over payment or charge any additional fees to Deposit Account No. 23-

Dated this  $2\sqrt{\pi}$  day of September, 2001.

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3178 of the undersigned.

PATENT TRADEMARK OFFICE

Respectfully submitted,

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